

We claim:

1. A method for controlling the initial movement of an electrosurgical electrode of
an electrosurgical device comprising:

initiating the delivery of energy to an electrosurgical electrode;

5 monitoring an electrical characteristic associated with the electrosurgical electrode;

determining when an arc has been initiated based upon the monitoring step; and

moving the electrosurgical electrode once the arc has been detected.

2. The method according to claim 1, wherein the monitoring step is carried out by
10 monitoring a change in electrical impedance.

3. The method according to claim 1, wherein the monitoring step is carried out by
monitoring a change in voltage.

15 4. The method according to claim 1, wherein the monitoring step is carried out by
monitoring a change in current.

5. The method according to claim 1, wherein the monitoring step is carried out by
monitoring electrical impedance.

20 6. The method according to claim 1, wherein the monitoring step is carried out by
monitoring voltage.

7. The method according to claim 1, wherein the monitoring step is carried out by monitoring current.

8. The method according to claim 5, wherein the monitoring step is carried out by
5 monitoring for an electrical impedance over 500 ohms.

9. The method according to claim 1, wherein the moving step comprises automatically beginning moving the electrosurgical electrode once the arc has been detected.

10 10. The method of claim 1, further comprising the step of adjusting the energy delivered to the electrosurgical electrode based upon the monitoring step so to at least help maintain an effective arc.

11. The method of claim 1, further comprising the step of adjusting the speed of the
15 electrosurgical electrode based upon the monitoring step so to at least help maintain an effective arc.

12. A method for controlling the operation of a percutaneously-placed electrosurgical electrode of an electrosurgical device comprising:

delivering energy to a percutaneously-placed electrosurgical electrode to create an arc thereat while moving said electrode;

5 monitoring an electrical characteristic associated with the electrosurgical electrode; and
adjusting the energy delivered to the electrosurgical electrode based upon the monitoring step so to at least help maintain an effective arc.

13. The method according to claim 12, wherein the monitoring step is carried out by
10 monitoring a change in electrical impedance.

14. The method according to claim 12, wherein the monitoring step is carried out by monitoring a change in voltage.

15 15. The method according to claim 12, wherein the monitoring step is carried out by monitoring a change in current.

16. The method according to claim 12, wherein the monitoring step is carried out by monitoring electrical impedance.

20 17. The method according to claim 12, wherein the monitoring step is carried out by monitoring voltage.

18. The method according to claim 12, wherein the monitoring step is carried out by monitoring current.

19. The method according to claim 16, wherein the monitoring step is carried out by
5 monitoring for an electrical impedance over 500 ohms.

20. A method for controlling the operation of a percutaneously-placed electrosurgical electrode of an electrosurgical device comprising:

delivering energy to a percutaneously-placed electrosurgical electrode to create an arc
10 thereat while moving said electrode along a predetermined path;
monitoring an electrical characteristic associated with the electrosurgical electrode;
monitoring an expected position of said electrode along said predetermined path; and
adjusting the energy delivered to the electrosurgical electrode based upon the electrical
characteristic and expected position monitoring steps so to at least help maintain an effective arc.

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21. The method according to claim 20, wherein the monitoring step is carried out by monitoring a change in electrical impedance.

22. The method according to claim 20, wherein the monitoring step is carried out by
20 monitoring a change in voltage.

23. The method according to claim 20, wherein the monitoring step is carried out by monitoring a change in current.

24. The method according to claim 20, wherein the monitoring step is carried out by monitoring electrical impedance.

5 25. The method according to claim 20, wherein the monitoring step is carried out by monitoring voltage.

26. The method according to claim 20, wherein the monitoring step is carried out by monitoring current.

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27. The method according to claim 24, wherein the monitoring step is carried out by monitoring for an electrical impedance over 500 ohms.

28. An electrosurgical assembly comprising:
a cutting device comprising a catheter having a proximal end and a distal end and
an electrode carried by the distal end of the catheter;
a controller connected to the cutting device;
5 a data acquisition system connected to the controller, wherein the data acquisition
system is capable of monitoring voltage and current output;
a microprocessor connected to the data acquisition system for processing voltage
and current data from the data acquisition system; and
an electrosurgical generator connected to the data acquisition system,
10 wherein the controller initiates movement of the electrode upon arc initiation at
the electrode.

29. The electrosurgical assembly of claim 28, further comprising an electrically
isolated switch connecting the data acquisition system and controller.

30. The electrosurgical assembly of claim 29, wherein the electrically isolated switch
is an optical switch.

31. The electrosurgical assembly of claim 28, further comprising a return electrode
20 connected to the electrosurgical generator.

32. The electrosurgical assembly of claim 28, wherein the electrode has a proximal part and a distal part, the distal part connected to the distal portion of the catheter and movable between a retracted state and an outwardly extending, operational state.

5 33. The electrosurgical assembly of claim 28, wherein the cutting device further comprises a proximal end assembly, wherein the proximal end assembly comprises a first driver operably coupled to the electrode, constructed to (1) move the electrode from the retracted state, and (2) rotate the electrode about the axis, whereby a tissue section is separable from surrounding tissue by the moving electrode.

10 34. The electrosurgical assembly of claim 28, wherein the movement comprises rotation of the electrode about its axis.

15 35. The electrosurgical assembly of claim 28, wherein the microprocessor comprises logic to calculate the electrical impedance and determine the presence of an arc based on a change in electrical impedance.

20 36. The electrosurgical assembly of claim 28, wherein the microprocessor determines the presence of an arc based on a change in voltage.

37. The electrosurgical assembly of claim 28, wherein the microprocessor determines the presence of an arc based on a change in current.

38. The electrosurgical assembly of claim 28, wherein the microprocessor determines the presence of an arc based on electrical impedance.

39. The electrosurgical assembly of claim 28, wherein the microprocessor determines
5 the presence of an arc based on voltage.

40. The electrosurgical assembly of claim 28, wherein the microprocessor determines the presence of an arc based on current.

10 41. The electrosurgical assembly of claim 38, wherein the presence of the arc is determined by an electrical impedance over 500 ohms.

42. The electrosurgical assembly of claim 28, wherein the controller, data acquisition system, electrosurgical generator, and microprocessor are integrated into a single control unit.

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43. An electrosurgical assembly comprising:

a cutting device comprising a catheter having a proximal end and a distal end and
an electrode carried by the distal end of the catheter;

a controller connected to the cutting device;

5 a data acquisition system connected to the controller, wherein the data acquisition
system is capable of monitoring voltage and current output;

an arc detection cable connecting the data acquisition system to the controller; and

an electrosurgical generator connected to the data acquisition system,

10 wherein the controller initiates movement of the electrode upon arc initiation at
the electrode.

44. The electrosurgical assembly of claim 43, further comprising a microprocessor
connected to the data acquisition system for processing voltage and current data from the data
acquisition system.

15 45. The electrosurgical assembly of claim 43, further comprising an electrically
isolated switch connecting the data acquisition system and controller.

46. The electrosurgical assembly of claim 43, wherein the electrically isolated switch
20 is an optical switch.

47. The electrosurgical assembly of claim 43, further comprising a return electrode
connected to the electrosurgical generator.

48. The electrosurgical assembly of claim 43, wherein the electrode has a proximal part and a distal part, the distal part connected to the distal portion of the catheter and movable between a retracted state and an outwardly extending, operational state.

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49. The electrosurgical assembly of claim 43, wherein the cutting device further comprises a proximal end assembly, wherein the proximal end assembly comprises a first driver operably coupled to the electrode, constructed to (1) move the electrode from the retracted state, and (2) rotate the electrode about the axis, whereby a tissue section is separable from surrounding tissue by the moving electrode.

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50. The electrosurgical assembly of claim 43, wherein the movement comprises rotation of the electrode about its axis.

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51. The electrosurgical assembly of claim 44, wherein the controller, data acquisition system, electrosurgical generator, and microprocessor are integrated into a single control unit.

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52. The electrosurgical assembly of claim 44, wherein the microprocessor comprises logic to calculate the electrical impedance and determine the presence of an arc based on a change in electrical impedance.

53. The electrosurgical assembly of claim 44, wherein the microprocessor determines the presence of an arc based on a change in voltage.

54. The electrosurgical assembly of claim 44, wherein the microprocessor determines the presence of an arc based on a change in current.

5 55. The electrosurgical assembly of claim 44, wherein the microprocessor comprises logic to calculate the electrical impedance and determine the presence of an arc based on electrical impedance.

56. The electrosurgical assembly of claim 44, wherein the microprocessor determines
10 the presence of an arc based on voltage.

57. The electrosurgical assembly of claim 44, wherein the microprocessor determines the presence of an arc based on current.

15 58. The electrosurgical assembly of claim 55, wherein the presence of the arc is determined by an electrical impedance over 500 ohms.

59. An electrosurgical assembly comprising:
a cutting device comprising a catheter having a proximal end and a distal end, and
an electrode carried by the distal end of the catheter;
a control unit connected to the cutting device comprising
5 an electrosurgical generator connected to the cutting device;
a data acquisition system connected to the electrosurgical generator,
wherein the data acquisition system is capable of monitoring the RF voltage and
current output;
a microprocessor connected to the data acquisition system for collecting
10 the voltage and current data from the data acquisition system; and
a controller connected to the data acquisition system, wherein the
controller initiates movement of the electrode upon arc initiation at the electrode.

60. The electrosurgical assembly of claim 59, wherein the movement comprises
15 rotation of the electrode about its axis.

61. The electrosurgical assembly of claim 59, wherein the microprocessor comprises
logic to calculate the electrical impedance and determine the presence of an arc based on a
change in electrical impedance.

20 62. The electrosurgical assembly of claim 59, wherein the microprocessor determines
the presence of an arc based on a change in voltage.

63. The electrosurgical assembly of claim 59, wherein the microprocessor comprises
determines the presence of an arc based on a change in current.

64. The electrosurgical assembly of claim 59, wherein the microprocessor comprises
5 logic to calculate the electrical impedance and determine the presence of an arc based on
electrical impedance.

65. The electrosurgical assembly of claim 59, wherein the microprocessor determines
the presence of an arc based on voltage.

10 66. The electrosurgical assembly of claim 59, wherein the microprocessor determines
the presence of an arc based on current.

67. The electrosurgical assembly of claim 64, wherein the presence of the arc is
15 determined by an electrical impedance over 500 ohms.

68. The electrosurgical assembly of claim 59, wherein the control unit further
comprises a power supply in communication with the controller.

20 69. The electrosurgical assembly of claim 59, wherein the controller controls a DC
motor.